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**ORIGINAL TO FOLLOW?** ☐ YES ☒ NO

### RESPONSE TO FINAL OFFICE ACTION DATED DECEMBER 20, 2005

**TITLE:** Method and Apparatus for Infilmm Defect Reduction for Electrochemical Copper Deposition  
**U.S. SERIAL NO.:** 10/774,194  
**FILING DATE:** February 5, 2004  
**INVENTOR:** Huang  
**EXAMINER:** Quovaunda Jefferson  
**GROUP ART UNIT:** 2823  
**CONFIRMATION NO.:** 6951

### CONFIDENTIALITY NOTE

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